



INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)	ATTY. DOCKET NO. 043890-0646	SERIAL NO. 10/712,305
APPLICANT Hiroyuki KITA, et al.		
FILING DATE November 14, 2003		GROUP 2834

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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NB		JP 62-057265	3-12-1987	Nippon Telegr & Teleph Corp <NTT>		English Abstract	
		EP 1 202 273 A2	5-2-2002	Matsushita Electric Industrial Co., Ltd.		X	
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
ND		DUNN et al., "Substrate effects on domain structures of PZT 30/70 sol-gel films via PiezoAFM" Journal of the European Ceramic Society, Elsevier Science Publishers, Barking, Essex, GB, Vol. 22, no. 6, 2002, pp. 825-833, XP004339372
NS		KANNO et al., "Piezoelectric properties of c-axis oriented PbZr,TiO ₃ thin films", Applied Physics Letters, AIP, American Institute of Physics, Melville, NY, US, vol. 70, no. 11, March 17, 1997, pp. 1378-1380, XP012017420

EXAMINER'S SIGNATURE PRIMARY EXAMINER <i>[Signature]</i>	DATE CONSIDERED 9-10-06
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